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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		Application Number	09/352,362
		Filing Date	July 13, 1999
		First Named Inventor	Shunpei YAMAZAKI et al.
		Group Art Unit	2815
		Examiner Name	J. Diaz
Sheet 1 of 1	Attorney Docket Number	0756-1996	

U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
P		5,620,910		Teramoto	04/15/1997	

FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>4</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
P		H. Furue et al., <i>Characteristics and Driving Scheme of Polymer-Stabilized Monostable FLC</i> Exhibiting Fast Response Time and High Contrast Ratio with Gray-Scale Capability, SID 1998, pp. 782-785.	
P		S. INUI et al., <i>Thresholdless Antiferroelectricity in Liquid Crystals and its Application to Displays</i> , J. Mater. Chem., 6(4), pages 671-673, 1996.	
P		AYA et al., <i>Improvement of SPC Poly-Si Film Using the ELA Method</i> , AM-LCD 97, Digest of Technical Papers, Vol. TFTP1-3, Pages 167-170, 1997.	
P		ABE et al., <i>High Performance Poly-Crystalline Silicon TFT's Fabricated Using the SPC and ELA Methods</i> , AM-LCD 98, Digest of Technical Papers, Vol. TFTP3-2, Pages 85-88, 1998.	

Examiner Signature	Date Considered	4/25/06
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.